

Notice of References Cited	Application/Control No. 10/689,741	Applicant(s)/Patent Under Reexamination CHANG, LIN-WEI	
	Examiner Janet M. Wilkens	Art Unit 3637	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,114,622	09-2000	Draeger, Ronald Michael	174/35R
	B	US-436,035	09-1890	Grothaus	292/303
	C	US-6,108,196	08-2000	Jung, Hee-duck	361/683
	D	US-6,042,157	03-2000	Shimotsu, Akihiro	292/83
	E	US-5,918,956	07-1999	Scholder, Erica	312/223.2
	F	US-6,082,842	07-2000	Ho, Hsin Chien	312/257.1
	G	US-952,657	03-1910	Watrous	292/128
	H	US-6,407,912	06-2002	Chen et al.	361/683
	I	US-5,717,571	02-1998	Helot, Jacques H.	361/685
	J	US-6,398,325	06-2002	Chen et al.	312/223.2
	K	US-6,824,174	11-2004	Lin et al.	292/85
	L	US-6,037,541	03-2000	Bartley et al.	174/66
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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